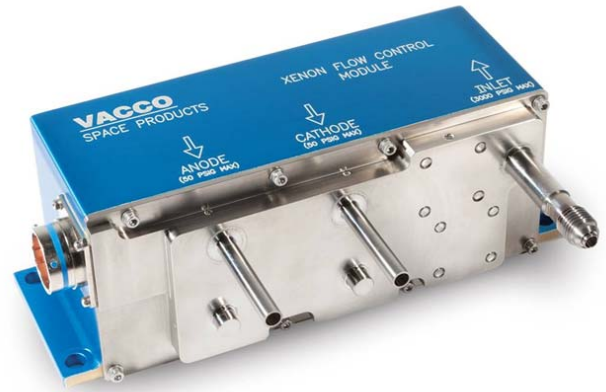


### DESCRIPTION

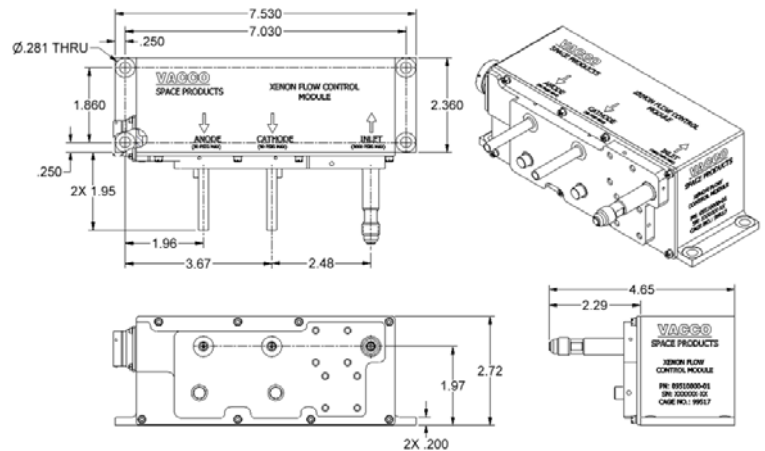
VACCO's Xenon Flow Control Module (XFCM) is a highly integrated ChEMS™ assembly designed for high reliability, tight leakage, and precise flow accuracy in a light weight module that consumes almost no power. The XFCM accepts Xenon directly from the storage tank eliminating the need for a pressure regulator. To maximize reliability the XFCM is series redundant against leakage and has been tested to NASA Technology Readiness Level 5. Qualification is in progress.

The XFCM is an all-welded manifold assembly of (10) components; System Filter, Isolation Valves, Proportional Valves and Pressure/Temperature Sensors. Each XFCM can independently control anode and cathode flow to an HET.



### FEATURES

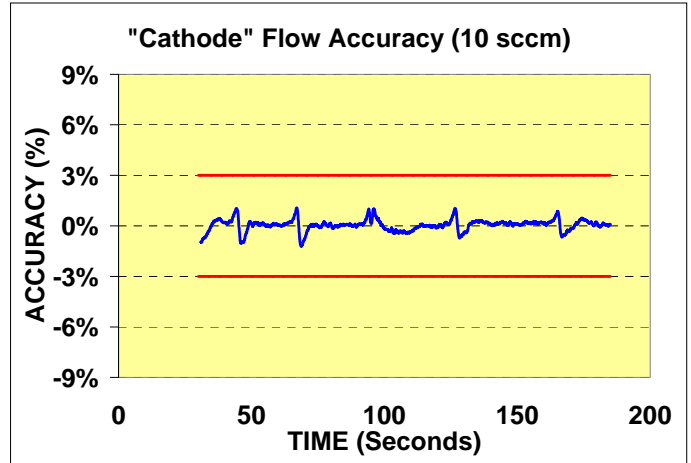
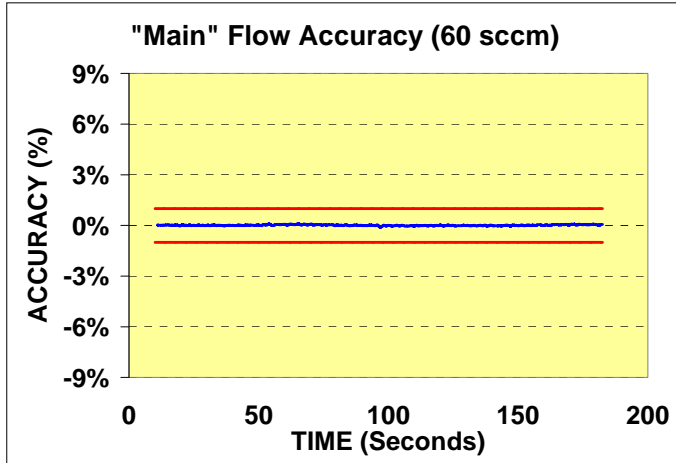
- ⊕ Inlet Pressure from 3,000 psi to 20 psi
- ⊕ 2-Channel Flow from 0.1 to 80 sccm
- ⊕ +/-1% Closed-Loop Flow Control Accuracy
- ⊕ Integral 10 micron Etched System Filter
- ⊕ Inlet High Pressure & Temperature Sensors
- ⊕ (3) Pressure & Temperature Sensors
- ⊕ Triple Redundant Against Internal Leakage
- ⊕ All-Welded Machined Titanium Manifold
- ⊕ Low Weight – 1.4 Kg (3.1 lbm)



### OPERATING PARAMETERS

Inlet Pressure Range.....	3000 to 10 psia	Inlet/Outlet Tubes .....	1/4" Ti (CRES optional)
Proof Pressure .....	4500 psia	Proportional Valve Voltage .....	0 to 130 vdc
Burst Pressure.....	7500 psia	Iso Valve Operating Voltage .....	20 – 33 vdc
Outlet Pressure Set-Point Range.....	0 to 50 psia	Iso Valve Response .....	< 20 mSec @ 24 vdc
Operating Temperature .....	0°C to +70°C	Pressure Transducer Output .....	0 to 5 vdc
Flow Range .....	0.1 to 80 sccm Xenon	Pressure Transducer Accuracy .....	+/-0.5% Full Scale
Anode Control Accuracy (Closed Loop).....	+/- 1%	Temperature Sensors .....	1000Ω RTD
Internal Leakage.....	<1 X 10 <sup>-3</sup> sccs GHe	Inlet Filter .....	10 microns absolute
External Leakage .....	<1 X 10 <sup>-6</sup> sccs GHe	Mass .....	<1.4 Kg (3.1 lbm)

### PERFORMANCE CHARACTERISTICS



### SCHEMATIC

